

**Notice of References Cited**

Application/Control No.

09/920,275

Applicant(s)/Patent Under  
Reexamination  
CHRYSLER ET AL.

Examiner

Scott B. Geyer

Art Unit

2829

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,696,665	12-1997	Nagy	361/723
	B	US-5,650,639	07-1997	Schrantz et al.	257/77
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Liu et al., "DIAMOND CHEMICAL VAPOR DEPOSITION: Nucleation and Early Growth Stages", 1995, pages 1-7.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a) )  
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